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CONFIRMATION NO. 3383

25944
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P.O. BOX 19928
ALEXANDRIA, VA 22320

FILING RECEIPT

Date Mailed: 09/10/2007

Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections**

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Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP05/06404 03/31/2005

Foreign Applications

JAPAN 2004-103913 03/31/2004
JAPAN 2004-167693 06/04/2004
JAPAN 2004-377336 12/27/2004
JAPAN 2005-055011 02/28/2005
JAPAN 2005-101835 03/31/2005
JAPAN 2005-102487 03/31/2005

If Required, Foreign Filing License Granted: 09/04/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is
US10/594,338

Projected Publication Date: 12/13/2007

Non-Publication Request: No

Early Publication Request: No

Title

Rare Earth Magnet and Method for Manufacturing Same

Preliminary Class

428

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